Research

Short Communication: Optical Properties of Intrinsic Silicon at 300 K

Martin A. Green and Mark J. Keevers

Centre for Photovoltaic Devices and Systems, University of New South Wales, Sydney 2052, Australia

An updated tabulation is presented of the optical properties of intrinsic silicon relevant to solar cell calculations. The absorption coefficient, refractive index and extinction coefficient at 300 K are tabulated over the 0.25–1.45 µm wavelength range at 0.01 µm intervals.

ccurate tabulations of the optical properties of silicon are of use in standardizing calculations of silicon solar cell properties and in extracting other cell parameters from experimental measurements.

Recent measurements at both the ultraviolet^{1,2} and infrared³ ends of the spectrum have considerably improved the accuracy of silicon optical data at these wavelengths, rendering past tabulations⁴⁻⁶ and assessments⁷ largely obsolete. An updated tabulation of the absorption coefficient, α , and the real and imaginary parts of the refractive index (*n* and *k*, respectively) is given in Table I. The extinction coefficient is related to the absorption coefficient via the relationship $\alpha = 4\pi k/\lambda$, where λ is the free space wavelength. Data are given at 300 K over the 0.25–1.45 µm wavelength range at 0.01 µm intervals.

The real refractive index (n) values to $0.8 \,\mu\text{m}$ wavelength are based on recent ellipsometric measurements, nominally at $22^{\circ}\text{C}^{.1}$ Extinction coefficients to $0.46 \,\mu\text{m}$ wavelength are deduced from the same measurements. In both cases, small corrections to convert to 300 K were based on temperature dependencies reported for both higher² and lower⁸ temperatures. Absorption coefficients were extracted from the extinction coefficient to $0.46 \,\mu\text{m}$ wavelength using the relationship given earlier. Beyond this wavelength, published absorption coefficient data^{3,9,10} are considered more accurate and the reverse procedure was used.

From 0.46 to 1.0 μ m, absorption coefficient data based on transmission measurements⁹ of samples in the 5.5–249 μ m thickness range were used, with a small correction to convert from the measurement temperature of 26°C. From 1.0 to 1.2 μ m, similar measurements upon specimens in the 0.03–1.77 cm thickness range¹⁰ form the basis of the data, again with temperature correction from the measurement temperature of 291 K. Beyond 1.2 μ m wavelength, recent absorption coefficient values deduced from sensitive spectral response measurements³ upon high-performance silicon cells are used.

At wavelengths beyond 1.0 μ m wavelength, real refractive index data were deduced by a critical examination of past literature.¹¹⁻¹⁴ The more recent data¹²⁻¹⁴ were consistent in that they all gave indices about 0.001–0.002 lower than the earlier data,¹¹ possibly owing to the use of purer silicon.¹⁴ When corrected to 300 K, the refractive index at wavelengths longer than 1 μ m could be described very accurately by the following expression, deduced from the discussion given by Moss *et al*,¹⁵

$$n^2 = 1 + \lambda^2 / (0.0938\lambda^2 - 0.00866) \tag{1}$$

where λ is in μ m. This was used to generate the data of Table I at wavelengths longer than 1 μ m.

When extrapolated to short wavelengths, this expression gives values about 0.015 lower than the ellipsometric data¹ at wavelengths near 0.8 μ m, just within the lower error bound of the latter data.¹

 λ(μm)	$\alpha(\text{cm}^{-1})$	n	k	λ(μm)	$\alpha(\mathrm{cm}^{-1})$	n	k
	1.04 1.06	1 (04					
0.25	1.84×10^{6}	1.694	3.666	0.70	1.90×10^{3}	3.774	0.011
0.20	1.9/ × 10°	1.800	4.072	0.71	1.77×10^{3}	3.762	0.011
0.27	$2.18 \times 10^{\circ}$	2.129	4.690	0.72	1.66×10^{3}	3.751	0.010
0.28	$2.36 \times 10^{\circ}$	3.052	5.258	0.73	1.54×10^{3}	3.741	0.009
0.29	2.24×10^{6}	4.426	5.160	0.74	1.42×10^{3}	3.732	0.008
0.30	1.73×10^{6}	5.055	4.128	0.75	1.30×10^{3}	3.723	0.008
0.31	1.44×10^{6}	5.074	3.559	0.76	1.19×10^{3}	3.714	0.007
0.32	1.28×10^{6}	5.102	3.269	0.77	1.10×10^{3}	3.705	0.007
0.33	1.17×10^{6}	5.179	3.085	0.78	1.01×10^{3}	3.696	0.006
0.34	1.09 × 10 ⁶	5.293	2.951	0.79	9.28×10^2	3.688	0.006
0.35	1.04×10^{6}	5,483	2.904	0.80	8.50×10^{2}	3.681	0.005
0.36	1.02×10^{6}	6.014	2.912	0.81	7.75×10^{2}	3.674	0.005
0.37	6.97×10^{5}	6.863	2.051	0.82	7.07×10^{2}	3.668	0.005
0.38	2.93×10^{5}	6.548	0.885	0.83	6.47×10^2	3 662	0.004
0.39	1.50×10^{5}	5.976	0.465	0.84	5.91×10^2	3.656	0.004
0.40	0.57 - 104	5 597	0 202	0.85	5 25 ~ 102	2 6 50	0.004
0.40	9.32×10 6 74 $\sim 10^4$	5 305	0.303	0.85	$3.33 \times 10^{-10^2}$	3.030	0.004
0.41	5.74×10^{-104}	5.303	0.220	0.80	4.00×10^{-1}	3.044	0.003
0.42	3.00 × 10	3.091	0.107	0.87	4.32×10^{2}	3.030	0.003
0.43	3.92×10^{-1}	4.925	0.134	0.88	3.83×10^{-1}	3.032	0.003
0.44	3.11 × 10 ⁻	4.793	0.109	0.89	3.43 × 10-	3.020	0.002
0.45	2.55×10^4	4.676	0.091	0.90	3.06×10^{2}	3.620	0.002
0.46	2.10 × 10⁴	4.577	0.077	0.91	2.72×10^{2}	3.614	0.002
0.47	1.72 × 10⁴	4.491	0.064	0.92	2.40×10^{2}	3.608	0.002
0.48	1.48 × 10⁴	4.416	0.057	0.93	2.10×10^{2}	3.602	0.002
0.49	1.27×10^4	4.348	0.050	0.94	1.83×10^{2}	3.597	0.001
0.50	1.11×10^{4}	4.293	0.045	0.95	1.57×10^{2}	3.592	0.001
0.51	9.70×10^{3}	4.239	0.039	0.96	1.34×10^{2}	3.587	0.001
0.52	8.80×10^{3}	4.192	0.036	0.97	1.14×10^{2}	3.582	0.001
0.53	7.85×10^{3}	4.150	0.033	0.98	9.59 × 10	3.578	0.001
0.54	7.05×10^{3}	4.110	0.030	0.99	7.92 × 10	3.574	0.001
0.55	6.39×10^{3}	4 077	0.028	1.00	640 x 10	3 570	0.001
0.56	5.78×10^{3}	4 044	0.026	1.01	5.11 × 10	3 566	-
0.57	5.32×10^{3}	4015	0.024	1.02	3.99×10	3 563	_
0.58	4.88×10^3	3 986	0.023	1.02	3.02×10	3 560	_
0.59	4.49×10^{3}	3.962	0.025	1.04	2.26×10	3.557	-
0.40	4.14 ~ 103	2 0 2 0	0.020	1.05	1.62 10	3 664	
0.00	4.14 × 10 ⁻	3.939	0.020	1.05	1.03 × 10	3.334	-
0.01	3.81×10^{3}	3.910	0.018	1.06	1.11 × 10	3.551	-
0.62	$3.52 \times 10^{\circ}$	3.893	0.017	1.07	8.0	3.548	-
0.03	$3.27 \times 10^{\circ}$	3.879	0.016	1.08	6.2	3.546	-
0.04	3.04 × 10°	3.801	0.015	1.09	4./	3.544	-
0.65	2.81×10^{3}	3.844	0.015	1.10	3.5	3.541	_
0.66	2.58×10^{3}	3.830	0.014	1.11	2.7	3.539	-
0.67	2.38×10^{3}	3.815	0.013	1.12	2.0	3.537	-
0.68	2.21×10^{3}	3.800	0.012	1.13	1.5	3.534	-
0.69	2.05×10^{3}	3.787	0.011	1.14	1.0	3.532	-

Table I. Optical properties of intrinsic silicon at 300 K. Data tabulated are the absorption coefficient (α), the real part (n) of the refractive index and the negative of the imaginary part (k, the extinction coefficient) for the wavelength range 0.25-1.45 μ m.

λ(μm)	$\alpha(\mathrm{cm}^{-1})$	n	k	λ(μm)	$\alpha(\mathrm{cm}^{-1})$	n	k
1.15	6.8×10^{-1}	3.530	-	1.30	4.5×10^{-5}	3.504	-
1.16	4.2×10^{-1}	3.528	-	1.31	2.7×10^{-5}	3.503	-
1.17	2.2×10^{-1}	3.526	_	1.32	1.6×10^{-5}	3.501	_
1.18	6.5×10^{-2}	3.524		1.33	8.0×10^{-6}	3.500	-
1.19	3.6×10^{-2}	3.522	-	1.34	3.5×10^{-6}	3.498	-
1.20	2.2×10^{-2}	3.520	_	1.35	1.7×10^{-6}	3.497	_
1.21	1.3×10^{-2}	3.528	-	1.36	1.0×10^{-6}	3.496	_
1.22	8.2×10^{-3}	3.516	_	1.37	6.7×10^{-7}	3.495	-
1.23	4.7×10^{-3}	3.515	_	1.38	4.5×10^{-7}	3.493	-
1.24	2.4×10^{-3}	3.513	-	1.39	2.5×10^{-7}	3.492	-
1.25	1.0×10^{-3}	3.511	-	1.40	2.0×10^{-7}	3.491	-
1.26	3.6×10^{-4}	3.510	-	1.41	1.5×10^{-7}	3.490	-
1.27	2.0×10^{-4}	3.508	-	1.42	8.5×10^{-8}	3.489	-
1.28	1.2×10^{-4}	3.507	-	1.43	7.7×10^{-8}	3.488	-
1.29	7.1×10^{-5}	3.506	-	1.44	4.2×10^{-8}	3.487	-
				1.45	3.2×10^{-8}	3.486	-

Table I—(continued)

Over the wavelength range of $0.8-1.0 \,\mu$ m, where there appeared to be no consistent experimental data of comparable accuracy, the data sets were merged using a wavelength-dependent weighting.

The error limits on the tabulated extinction and absorption coefficient data are estimated to increase from $\pm 0.3\%$ at 0.25 µm wavelength¹ to $\pm 4\%$ beyond 0.46 µm, $\pm 10\%$ beyond 1.2 µm and even larger beyond 1.4 µm wavelength. For the real part of the refractive index, the estimated accuracy is better than $\pm 0.1\%$ beyond 1.0 µm, increasing to about $\pm 0.5\%$ at shorter wavelengths, except below 0.3 µm where it increases to $\pm 1\%$.

Acknowledgements

One of the authors (M. A. G.) would like to thank H. A. Weakliem for providing tabulations of his published data sets and G. E. Jellison, Jr. for providing data prior to publication. Thanks are also due to one of the referees for suggesting an extra reference. This work was supported by the Australian Research Council. The Centre for Photovoltaic Devices and Systems is supported by the Australian Research Council and by Pacific Power.

REFERENCES

- 1. G. E. Jellison, Jr., 'Optical functions of silicon determined by two-channel polarization modulation ellipsometry', *Opt. Mater.*, 1, 41 (1992).
- 2. G. E. Jellison, Jr. and F. A. Modine, unpublished work.
- 3. M. J. Keevers and M. A. Green, 'The absorption edge of silicon from solar cell spectral response measurements', *Appl. Phys. Lett.*, **66**, 174 (1995).
- 4. D. F. Edwards, 'Silicon (Si)', in Handbook of Optical Constants of Solids, p. 547 (E. D. Palik, ed.), Academic Press, Boston, 1985.
- 5. M. A. Green, *High Efficiency Silicon Solar Cells*, Appendix C, pp. 228-231, Trans Tech Publications, Aedermannsdorf, 1987.
- 6. D. E. Aspnes, 'Optical functions of intrinsic Si', in Properties of Silicon, p. 72, INSPEC, IEE, London, 1988.

- 7. K. Bücher, J. Bruns and H. G. Wagemann, 'Absorption coefficient of silicon: an assessment of measurements and the simulation of temperature variation', J. Appl. Phys., 75, 1127 (1994).
- 8. G. E. Jellison, Jr. and F. A. Modine, Optical Constants for Silicon at 300 K and 10 K Determined from 1.64 to 4.73 eV by Ellipsometry, Report ORNL/TM-8002, Oak Ridge National Laboratory, February 1982.
- 9. H. A. Weakliem and D. Redfield, 'Temperature dependence of the optical properties of silicon', J. Appl. Phys., 50, 1491 (1979).
- 10. G. G. MacFarlane, T. P. McLean, J. E. Quarrington and V. Roberts, 'Fine structure in the absorption-edge spectrum of Si', *Phys. Rev.* 111, 1245 (1958).
- 11. C. D. Salzberg and J. J. Villa, 'Infrared refractive indices of silicon, germanium and modified selenium glass', J. Opt. Soc. Am., 47, 244 (1957).
- 12. F. Lukes, Czech. J. Phys., B10, 317 (1960).
- 13. W. Primak, 'Refractive index of silicon', Appl. Opt., 10, 759 (1971).
- 14. H. W. Icenogle, B. C. Platt and W. L. Wolfe, 'Refractive indices and temperature coefficients of germanium and silicon', Appl. Opt., 15, 2348 (1976).
- 15. T. Moss, G. J. Burrell and B. Ellis, Semiconductor Optoelectronics, pp. 25-26, Butterworth, London, 1973.